



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1734**

PATENT

Attorney Docket No. 02887.0271

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tetsuya KUROSAWA et al.

Application No.: 10/808,298

Filed: March 25, 2004

For: SEMICONDUCTOR
MANUFACTURING APPARATUS
AND METHOD OF
MANUFACTURING
SEMICONDUCTOR DEVICE

)
)
) Group Art Unit: 1734

) Examiner: Osele, Mark A.

) Confirmation No.: 5493

) Mail Stop AF

Okay to Enter

mao 7-13-06

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed April 5, 2006, the period for response to which extends through July 5, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.